



IFW

Docket No.:0756-7223

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Koichiro TANAKA)
Serial No. 10/721,075) Group Art Unit: 1725
Filed: November 26, 2003) Examiner: Maria Elve
For: LASER IRRADIATION APPARATUS,)
LASER IRRADIATION METHOD, AND METHOD)
FOR MANUFACTURING A SEMICONDUCTOR
DEVICE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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Timmy J. Duran

REQUEST FOR STATUS

Honorable Commissioner of Patents

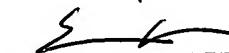
P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,


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